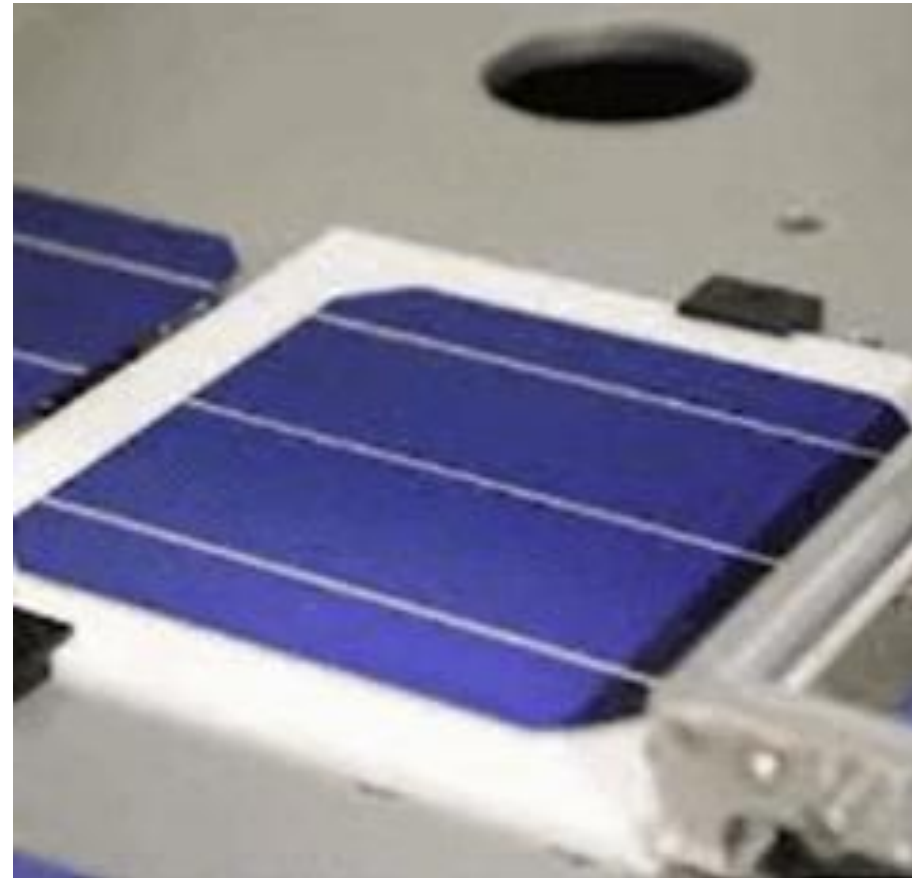




Process Innovations in Additive and 3D Electronics – From Analogue to Digital

Addressing issues like speed, resolution, digital, material choice, etc

**Printed Electronics is Everywhere
- From diapers to precision missiles!**



Agenda: „Process“ Innovations

From screen to dry inkjet less laser printing

#Screen #Capillary #Dispensing #Inkjet #EHD #Microdispensing #LIFT
#LaserPrint #DryMultiMaterial and Beyond

No Time For Material or Application Innovations 🥲 🥲



BOSTON • USA • 2025
11-12 JUNE
CONFERENCE • EXHIBITION

70+

SPEAKERS

TALKS 11 JUNE		
TRACK 1	TRACK 2	TRACK 3
 Rochester Institute of Technology  NASA Goddard  BOEING  essentec <small>Air Conditioning Technology</small>	 SPARK <small>SPARKS</small>  GE HealthCare  Heraeus <small>Electronics</small>	 UNIVERSITY OF MARYLAND  primways  AMES GOLDSMITH  CREATIVE MATERIALS
 EPICORE <small>BIOSYSTEMS</small>  VTT  GlaxoMedicines  Nagase Chemicals	 HRL <small>LABORATORIES</small>  NOTION <small>SYSTEMS</small>  ORACULA  C-INK	 brewer science  NOVACENTRIX  iris <small>light technology</small>  penacool <small>Penacool & Co.</small>
 IEE <small>International Electrotechnical Commission</small>  GREEN-SOLAR  Henkel  KIMOTO	 IOXTECH <small>ATLANT 3D</small>  TEXAS <small>UNIVERSITY</small>	 GrapheneDx  SunChemical <small>an affiliate of Dow Chemical Company</small>  IdentifySensors  CommuniGate
 ACI <small>AUTOMATA</small>  Satosen <small>INC. USA</small>  NC STATE <small>UNIVERSITY</small>	 Panasonic  ICARBE CHEM <small>INC.</small>  MICROCONTINUM	 Georgia <small>Tech</small>  ETS <small>INSTITUTE OF TECHNOLOGY</small>  UNIVERSITY OF CHICAGO

TALKS 12 JUNE	
TRACK 1	TRACK 2
   	   
  	  
  	  
  	  
EVENT ENDS	

75+

EXHIBITORS





THE FUTURE OF ELECTRONICS RESHAPED

BERLIN • EU • 2025
22-23 OCT
CONFERENCE • EXHIBITION

Perovskite⁺Connect  THE FUTURE OF ELECTRONICS **RESHAPED**

The Co-Located Events Will Jointly Welcome



550

PARTICIPANTS



80

EXHIBITORS



70

PRESENTATIONS



12

MASTERCLASSES



4

TOURS

22-23 OCTOBER
2025

THE FUTURE OF ELECTRONICS
RESHAPED

FLOORPLAN EUROPE

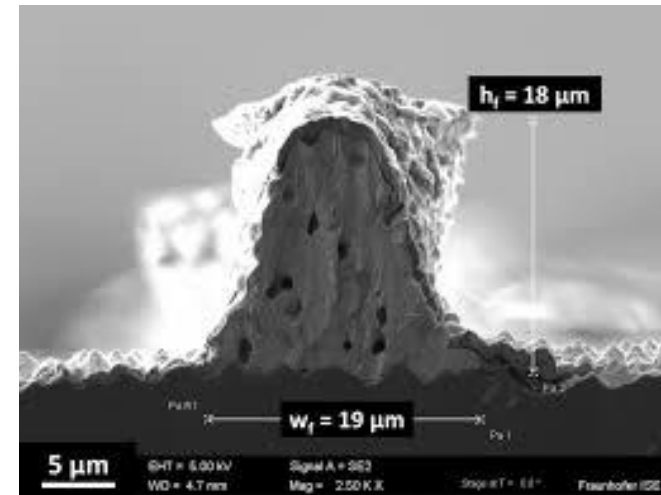
 RESERVED
 BOOKED

Co-located with

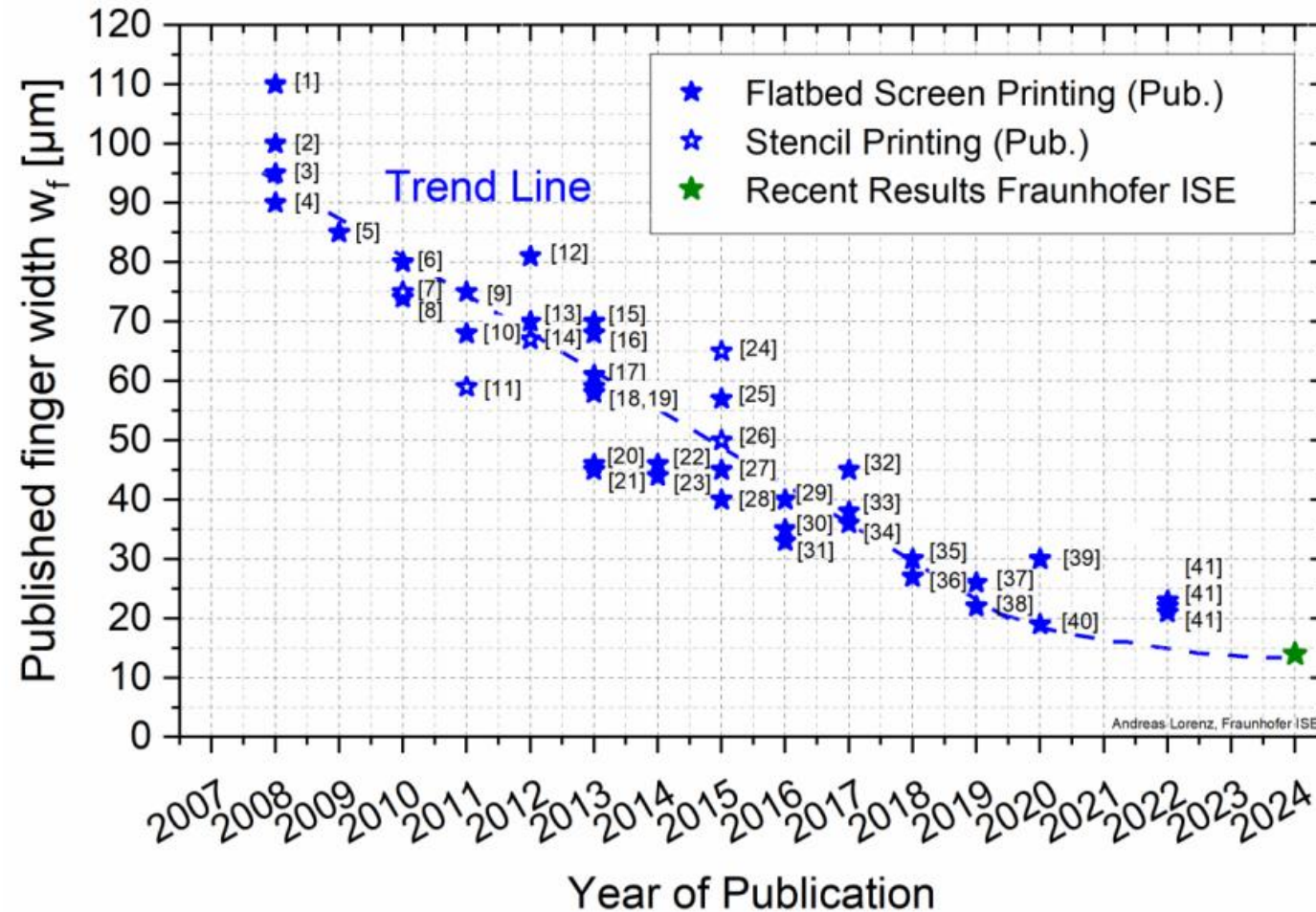
Perovskite⁺Connect



Incredible linewidth improvement in screen printed photovoltaic metallisation....

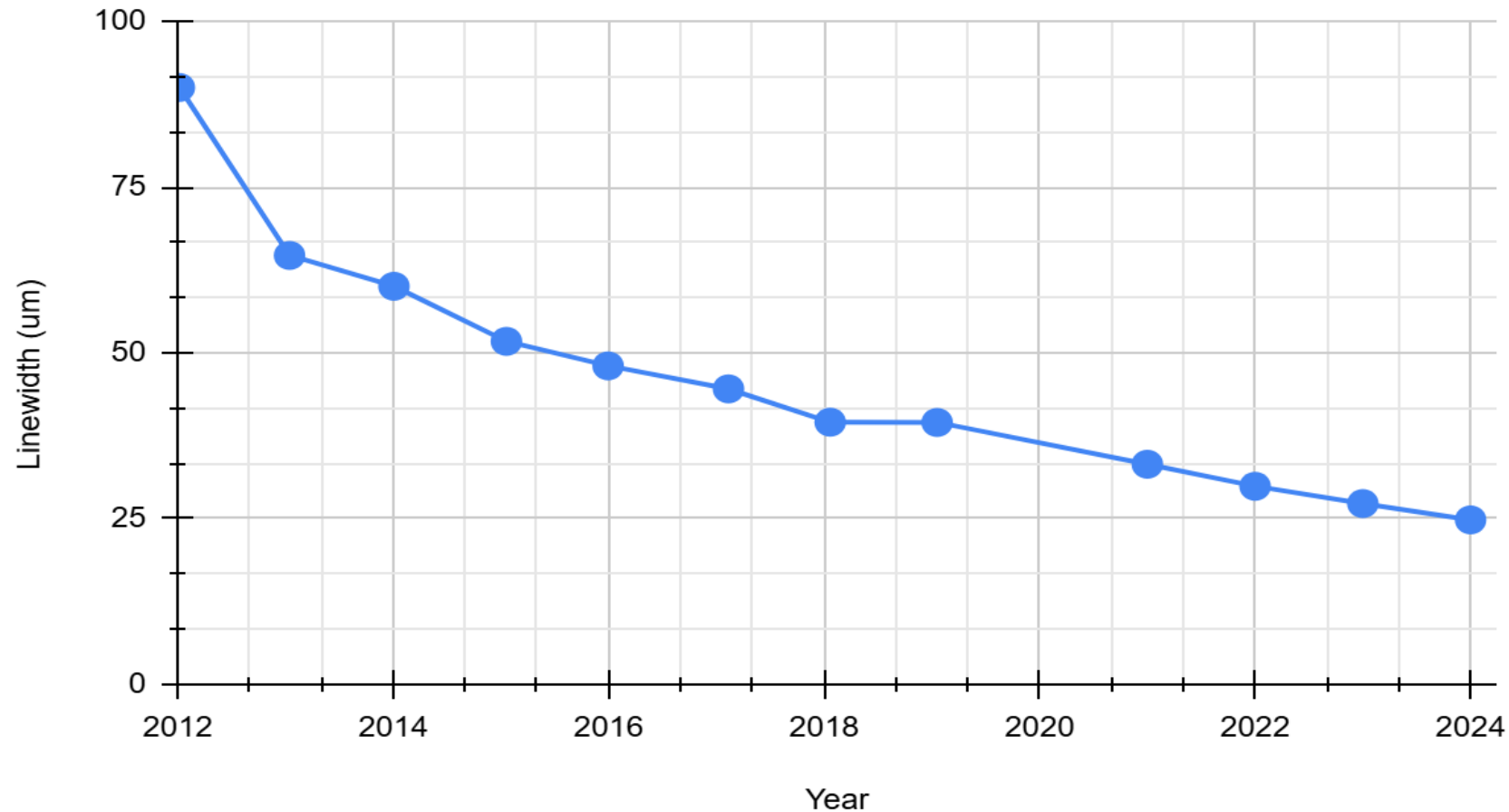


Research progress in ultrafine screen printed fingers



Sources: Tepner & A. Lorenz, „Printing technologies..”, Progress in Photovoltaics, 2023

And the industry has followed...



Sources: TechBlick compilation
from ITRPV roadmap data

Team work: Paste and screen evolution

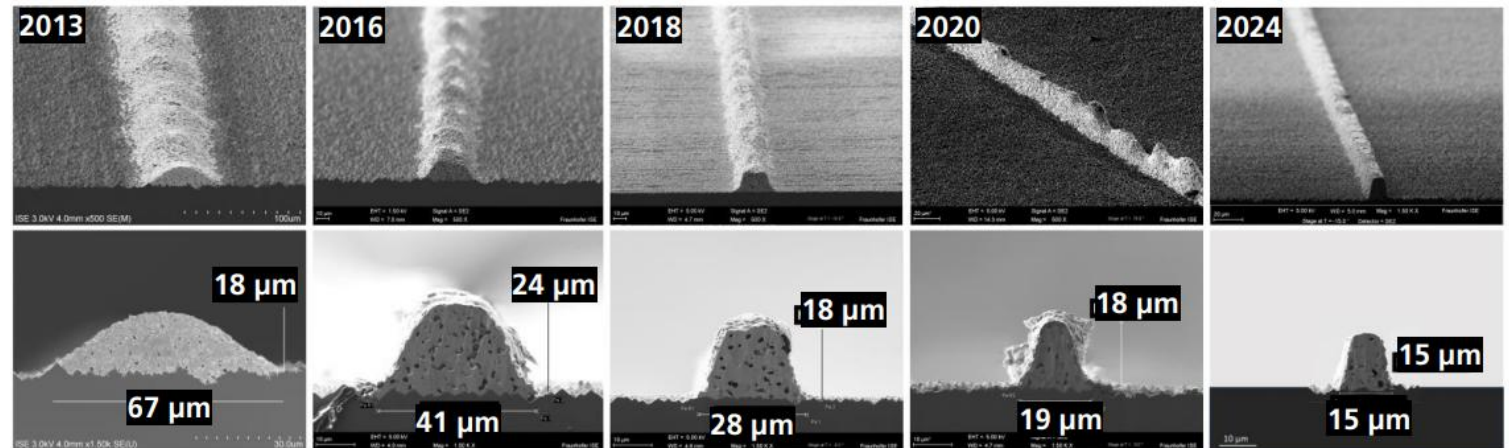
Paste optimization
(rheology, particle size,
wall slip)

Ultra fine stainless
steel meshes (today:
520-11 mesh)

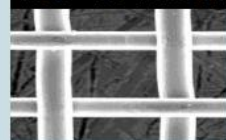
Laser opening of
screens (channel width
< 20 μm)

Paste optimization ^[8]

- Rheology parameters / Particle size
- Wall slip behaviour



400-18 mesh



Screen optimization (finer meshes) ^[9]

- More (stainless steel) wires per inch
- Finer wires (today: 11 μm thickness)

520-11 mesh



Sources: Fraunhofer ISE

Not just linewidth but also production speed...

Incredible print speeds and parallelisation

XDL-DP-Topcon



Source: Suzhou Maxwell Technologies Co., Ltd.

Item	182mm	210mm
Throughput	14400 pcs/h @half size	12521 pcs/h @half size
Printing Speed	490mm/s	400mm/s
Ink Return Speed	1300mm/s	1200mm/s
CT	≤1s	≤1.15s
Printing Accuracy	±20μm(Mark point positioning)	
Uptime	≥95%	
Breakage Rate @130μm	≤0.2%	≤0.23%
MTTR	2 hours	
MTBF	200 hours	

Half-cell TOPCon printing as example

Full wafer turnkey solution in industry now 8470 PCS Wafer/Hour @M10



Automatic full solar wafer screen printing



The “X” DUAL Lane production line provides a printing capacity up to 8,470 pcs/hour, a breakage rate less than 0.2%, and a printing accuracy up to $\pm 6\text{ }\mu\text{m}$, which significantly improves the throughput and yield of solar cells.

Compatible for M6 to G12 Wafer Size **NET THROUGHPUT :**
7578 PCS Wafer/Hour @G12 450 MW / Year for G12
8470 PCS Wafer/Hour @M10 580 MW / Year for M10

INTRODUCTION YEAR: MAY 2023

Item	Technical Index
Throughput (pcs/hour) and Wafer Size	8470 pcs@182mm wafer, CT≤0.85s; 7578 pcs@210mm wafer, CT≤0.95s;
Printing Accuracy	Up to $\pm 6\mu\text{m}$ (Mark Point Positioning with 4 cameras)
Uptime	≥98%
Breakage Rate	≤0.2%
MTTR	2 hours
MTBF	200 hours

Can we do rotary screen printing....?



Rotary screen printing
(single lane) → up to 8000
Wafer/h (cycle time of 0.45
s)

SHJ PVs

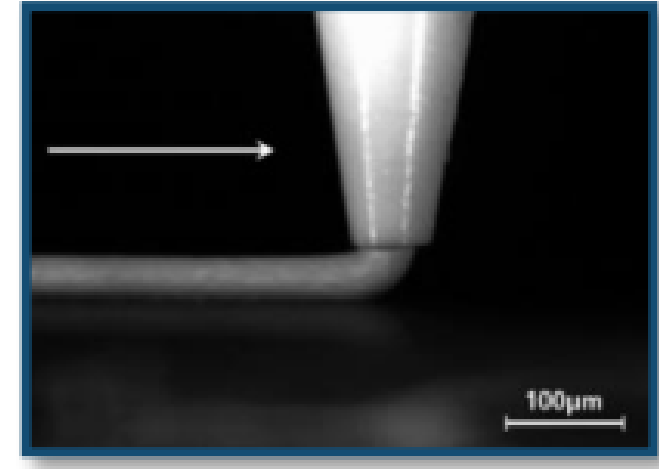
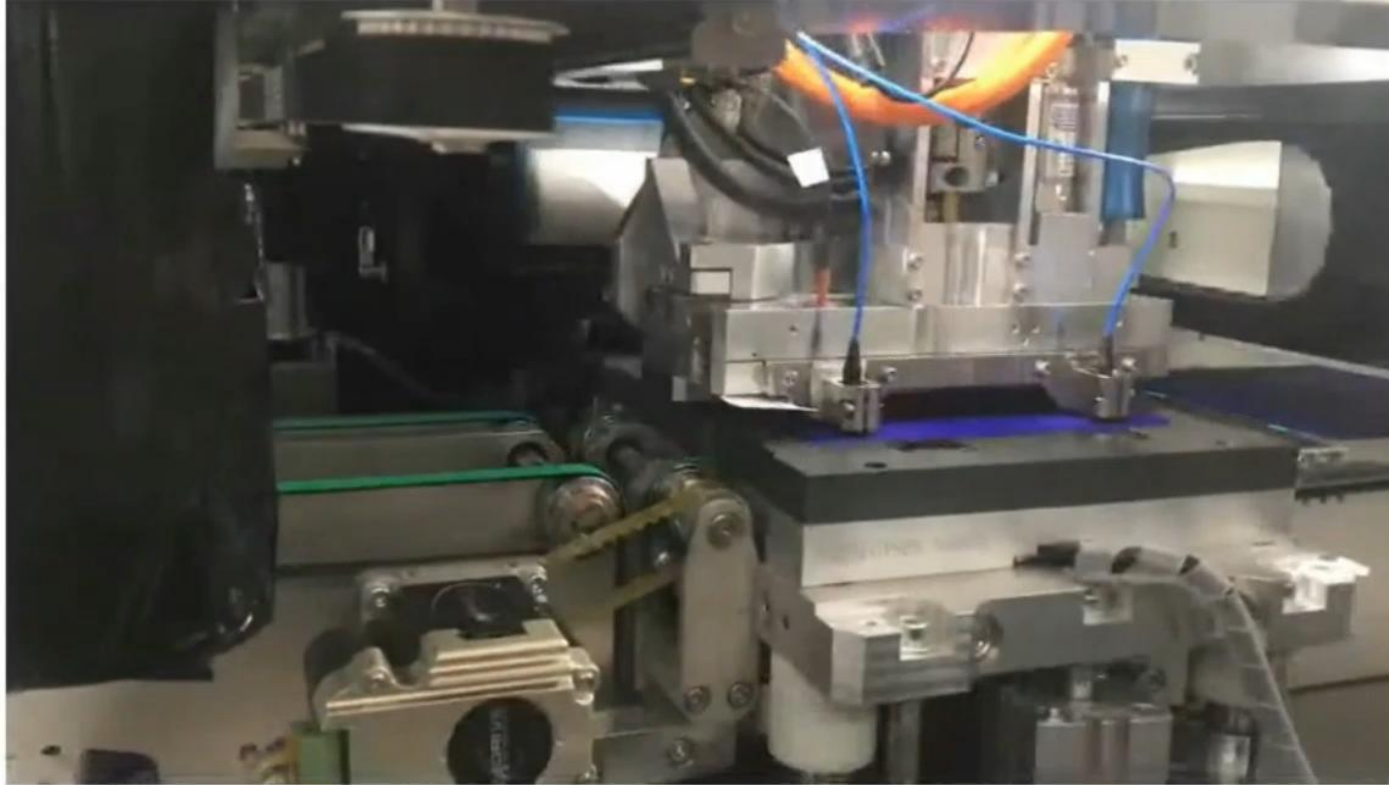
50um linewidth or so



Source: Fraunhofer ISE

And many approaches going beyond screen printing in photovoltaic metallisation....

Parallel homogeneous extrusion of metallization pastes



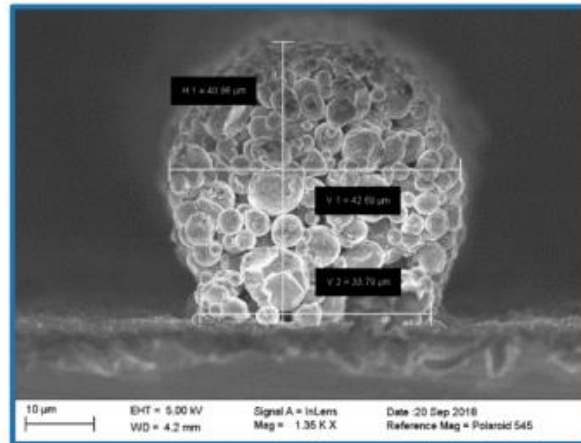
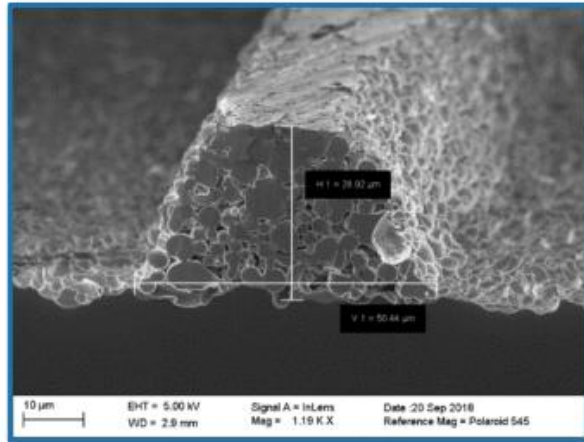
Finger width: 20µm

Speed: 500-1000 mm/s

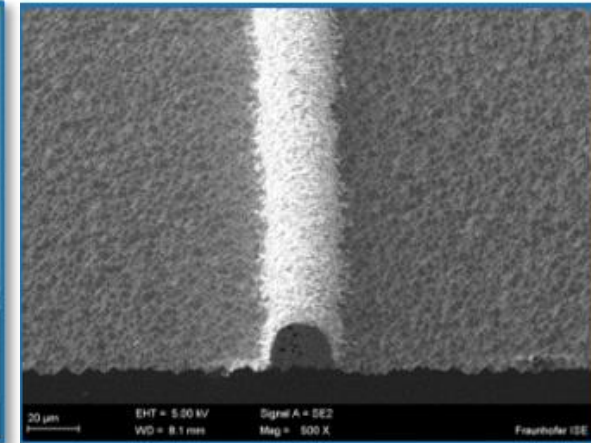
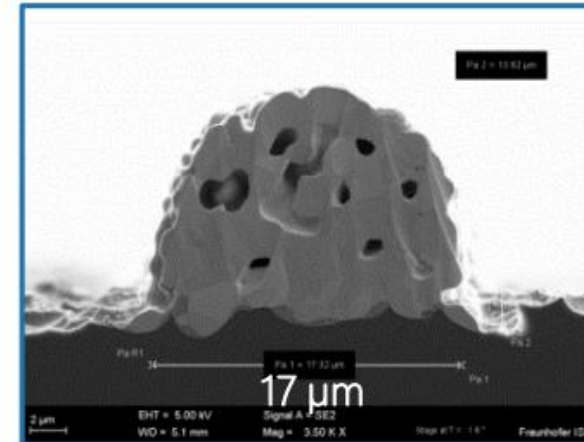
Source: HighLine Technology

Narrow fingers with good aspect ratio.

Aluminum



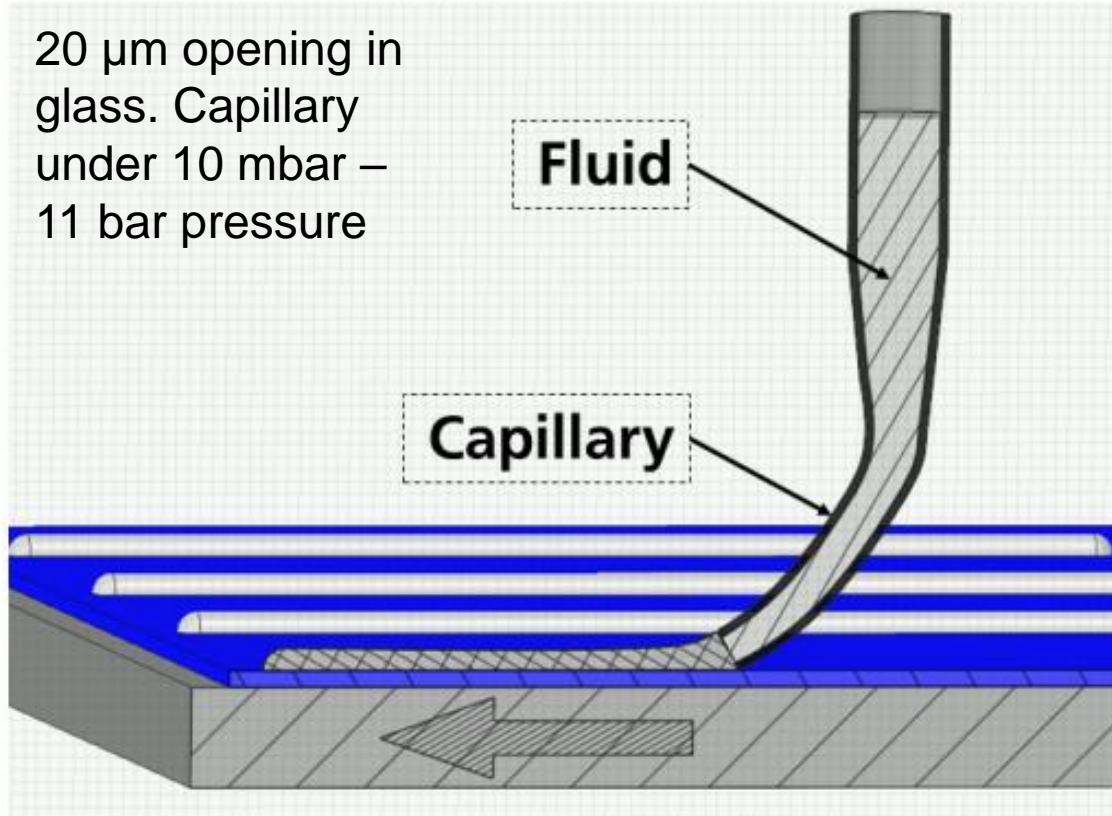
Silver



Source: HighLine Technology

Capillary printing under pressure

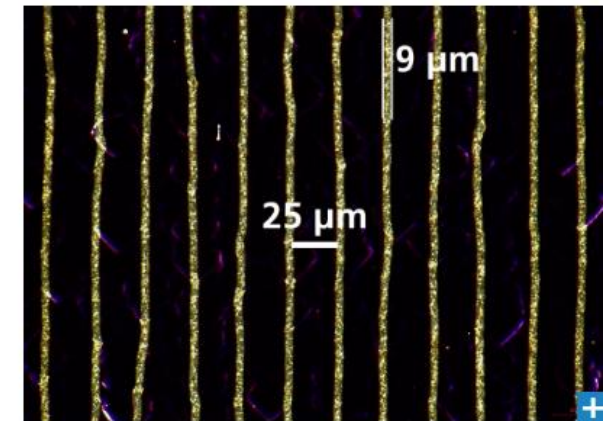
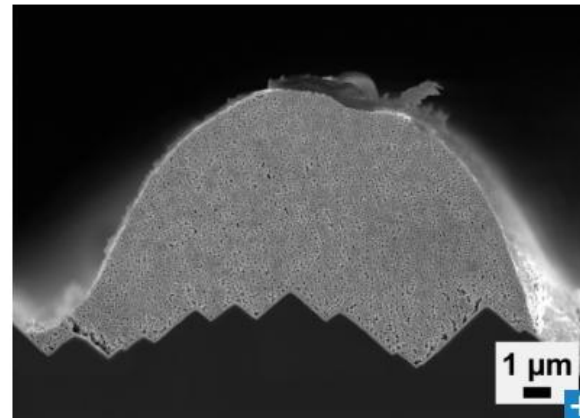
20 μm opening in glass. Capillary under 10 mbar – 11 bar pressure



Finger width: 12 μm ■ Finger height: 6.4 μm
SHJ efficiency 22.96 % ■ 60% silver saving compared to screen printing

Speed can be 500mm/s

Ag NP inks



Source: Fraunhofer ISE

Now lets switch from analoge to inkjet and DIGITAL printing

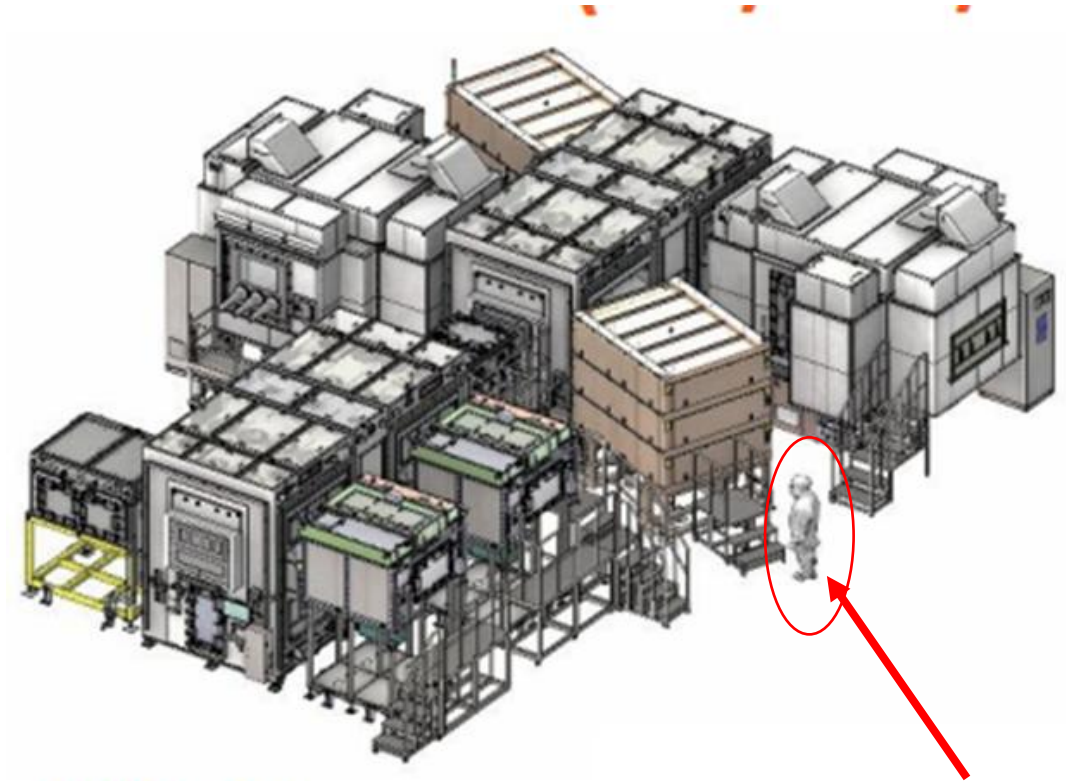
Inkjet sets the reference but many questions:
scale, stability, material choice, resolution, etc

So first question was: can IJP be scaled??

HUGE IJ printers for area and (future) pixel printing



Gen 6.5 (925x1500mm)



YIELDjet® Lassen
(TFE/MLP/PHF Mass
Production)
925mm x 1500mm

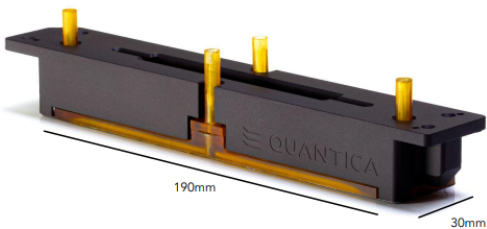
Source: Kateeva

And can we digitally print high viscosity (even screen printable) pastes....?

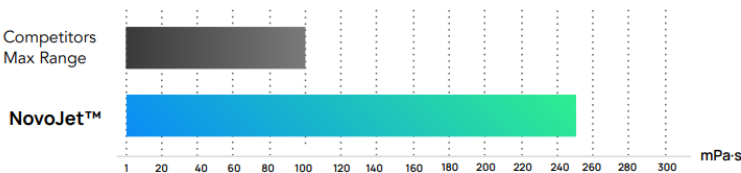
Jetting higher viscosity materials...

NovoJet™ Printhead

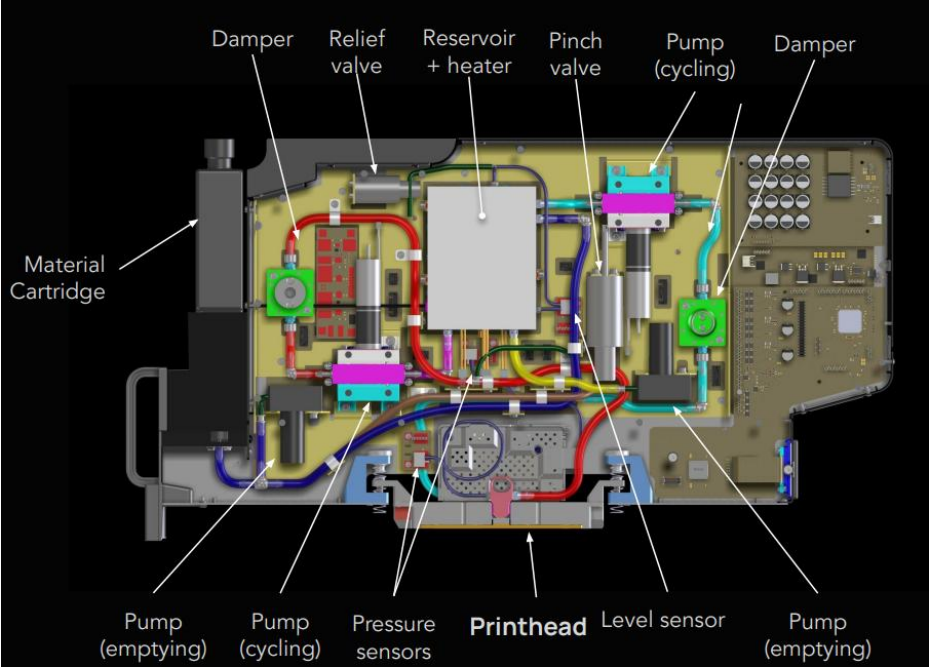
Developed by Quantica, manufactured by Xaar



Viscosity ranges (Jetting Temperature) of inkjet printheads on the market

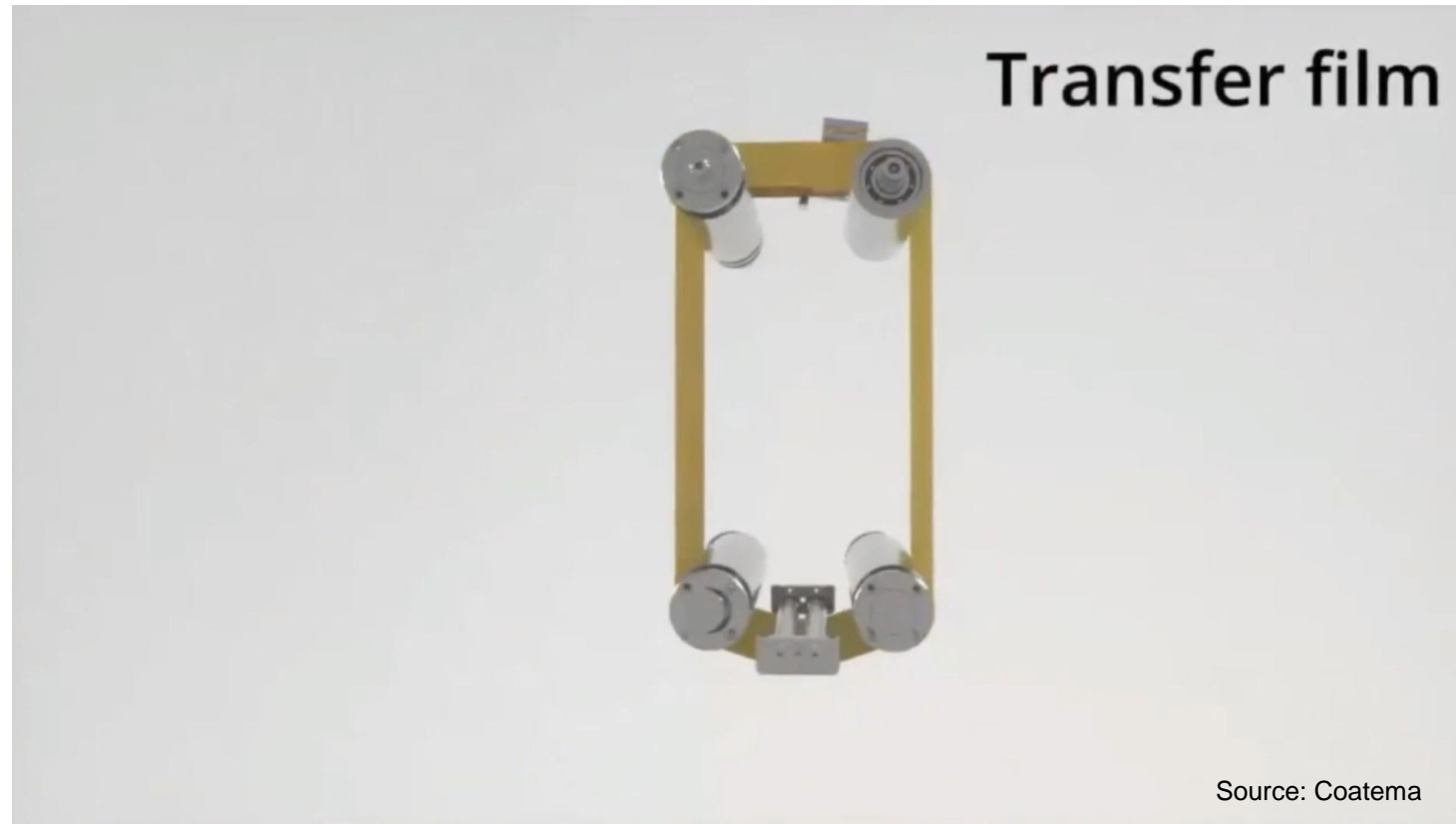


Nozzle Count	96
Rows of Nozzles	1
Nozzle Pitch	1.27mm
Fluid Viscosity Range (Jetting temp)	1 mPa • s – 250 mPa • s
Operation Temperature	15C-80C
Frequency	8kHz
Surface Tension	1-750 mN/m
Flow Type	Full Nozzles Recirculation
Nozzle Plate	Polyimide



- Curing starts in print head?
 - Low nozzle count (20 per inch)
- Source Quantica

LIFT: R2R digital laser printing of high viscosity materials

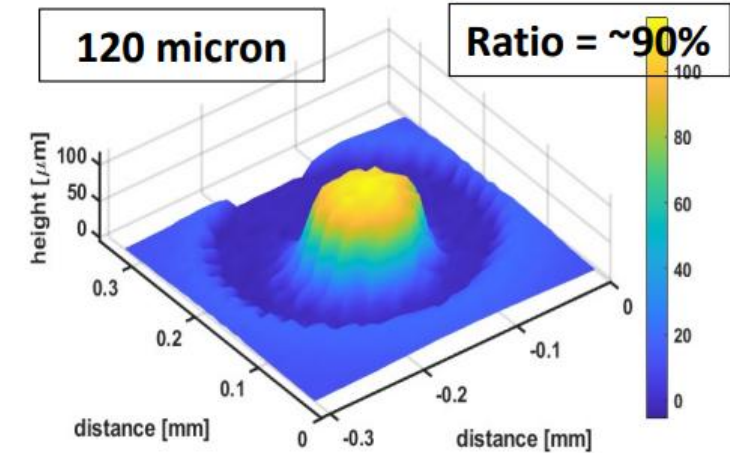
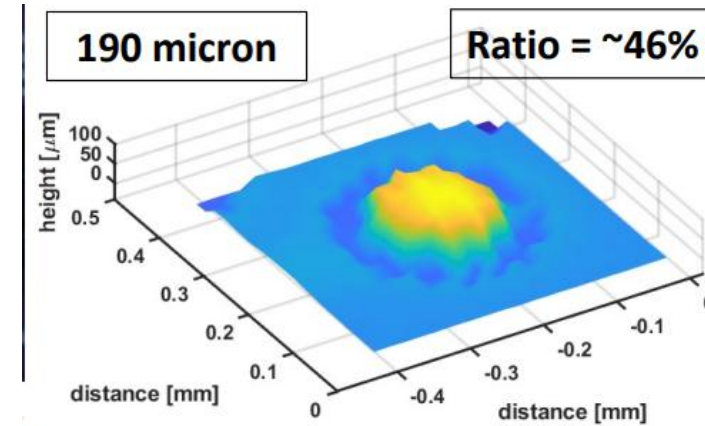


Wide range of viscosity with modest resolution

Material	Viscosity range (KcPs)	Cure type	Resolution	Filler size
Acrylate & Methacrylate	0.5-70	UV	40 µm	up to 2 µm
Epoxy - 2K	5-70	UV & heat	50 µm	up to 2 µm
Silicone - 1K & 2K	10-300	UV & heat	100 µm	up to 2 µm
Metal paste (Ag & Cu)	5-40	Sintering	80 µm	0.1-5 µm
Solder paste - type 4 to 9	20-40		50 µm - 250 µm	3-35 µm
Solder mask	20-40	UV / heat	40 µm	up to 2 µm
Polyurethane (acrylate)	0.5-70	UV	40 µm	up to 2 µm
Ceramic paste	0.5-70		40 µm	up to 2 µm
Carbon paste	20-40		100 µm	wires of ~10 µm
Polyimides	0.5-2	UV	40 µm	up to 2 µm

Source: io-Tech

Exmample: Solder printing



T6@120um and T9@45um with 5M drops/hr (13888 dots per sec)

Source: io-Tech 2023



Can we do R2R with LIFT....



Print width 180 mm

Print speed 2-10 m/min

Resolution: up to 600 dpi

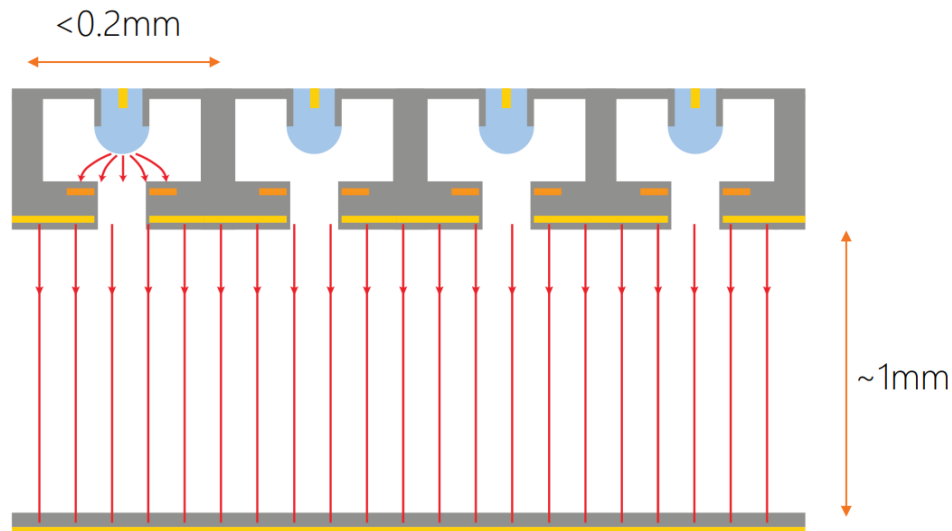
Source: Coatema

And can one have high viscoisty digital printing AND ultra fine resolution beyond inkjet...?

EHD Printing: MEMS multi-nozzles enable high productivity

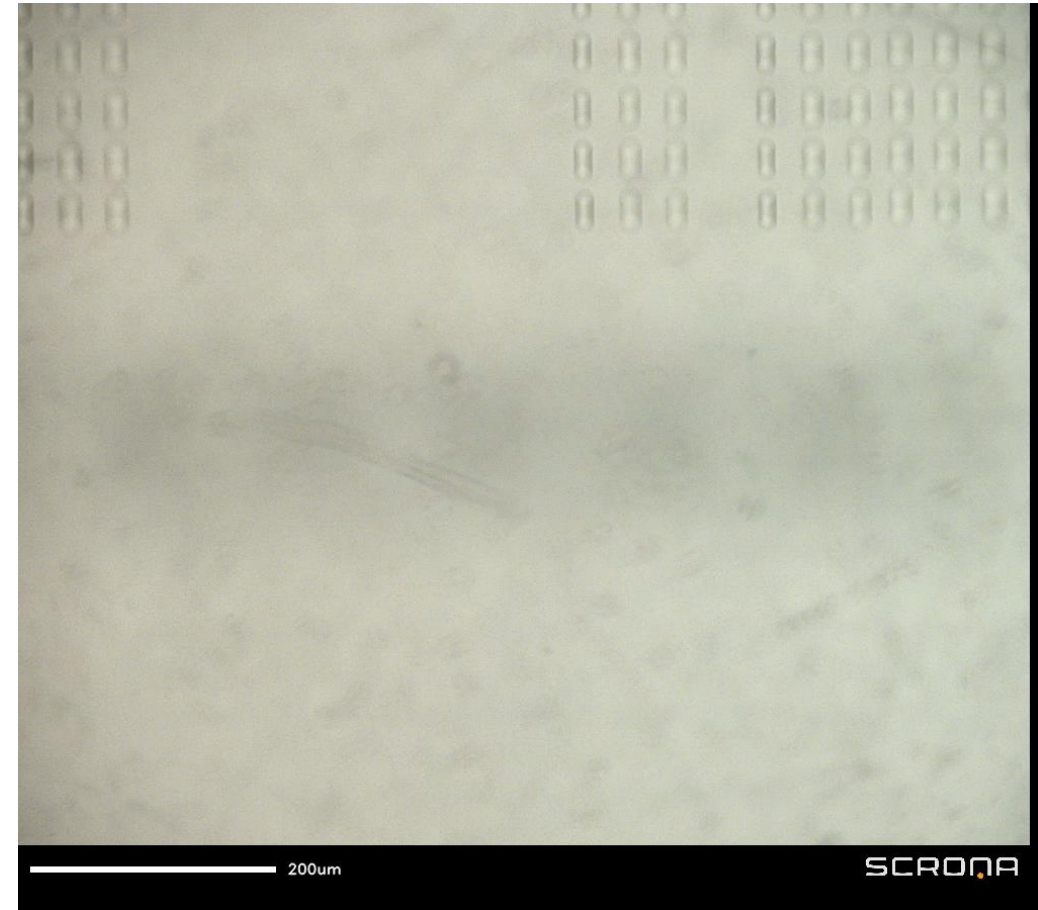
Printing QDs with 128 heads

Scrona MEMS multi-nozzle printhead

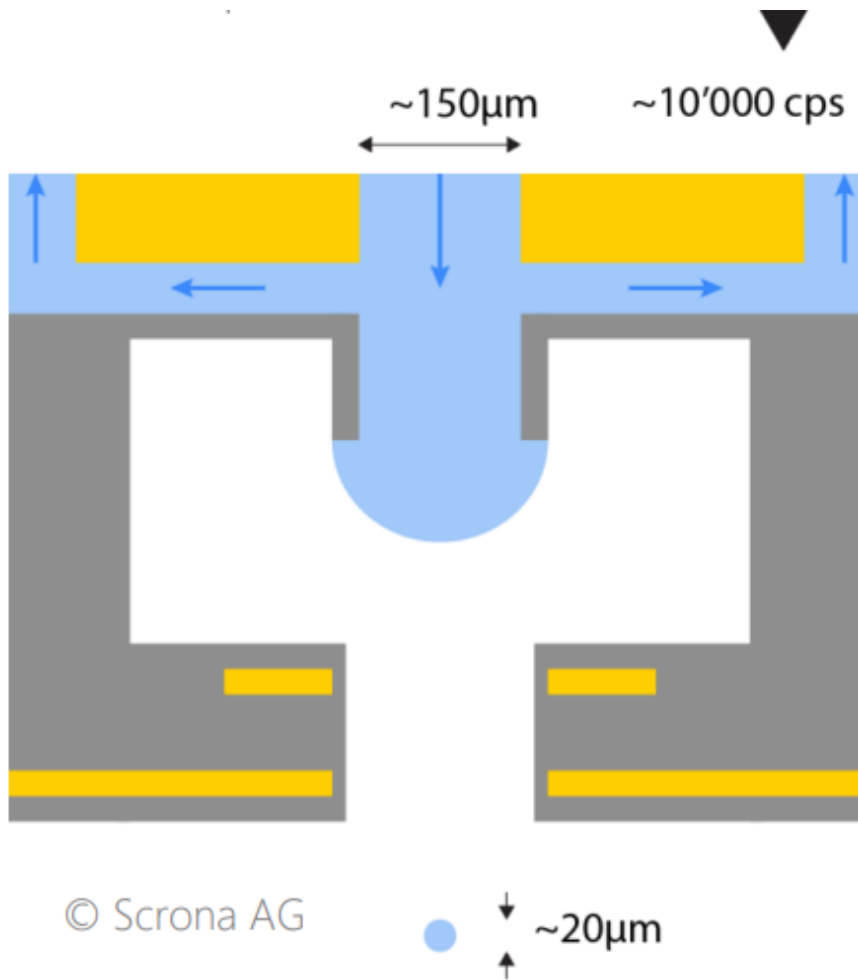


Resolution $< 0.5\ \mu\text{m}$
Viscosity $> 10'000\ \text{cP}$

Source: Scrona



But how to accomodate really viscous pastes like adhesives with EHD printing...?

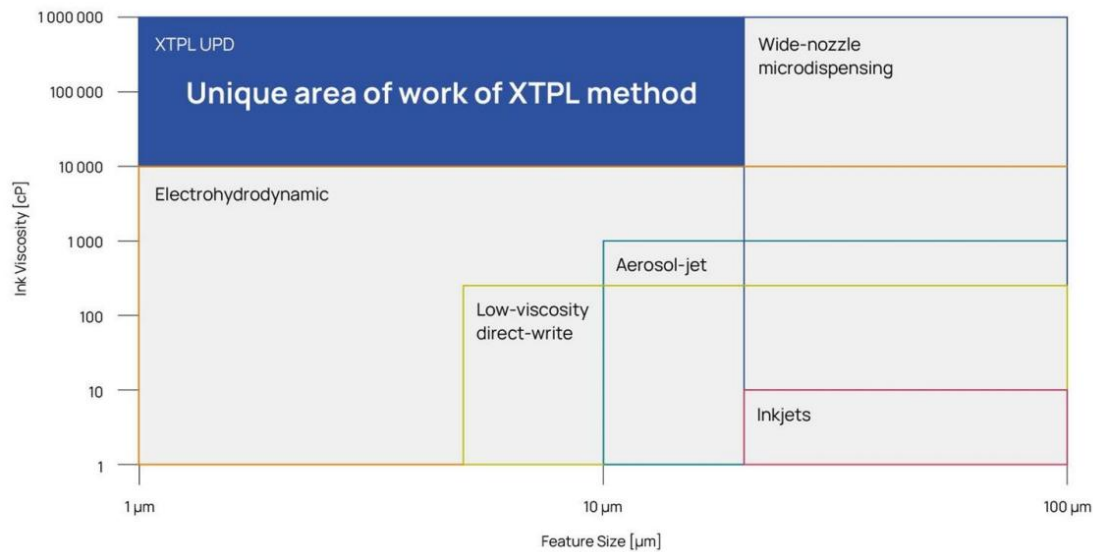


Threebond 3065E,
7Pas/700cP,
printing at up to
 $\sim 100\text{Hz}$ Size of
droplet easily
adjustable from
below 10micron to
>50micron



But can we go even higher viscosity levels for eg higher conductivity without e-field?

Micro-dispensing technology (UPD)



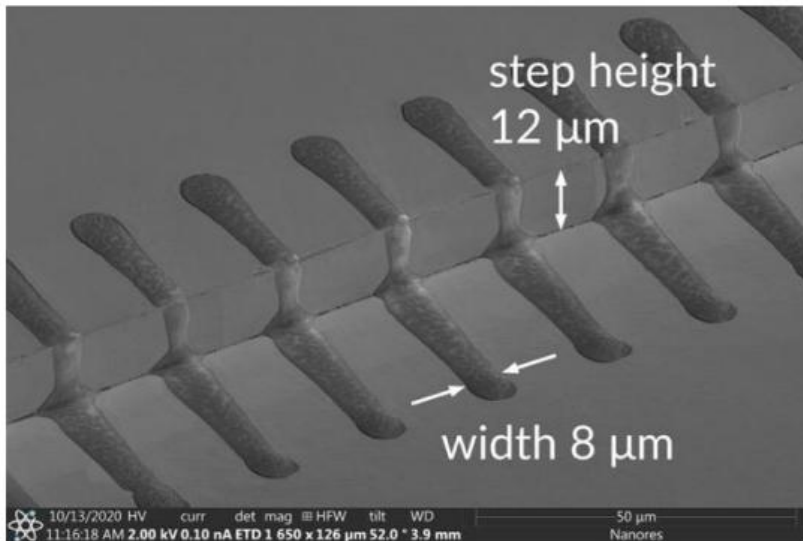
■ A unique area of XTPL where no competing methods exist
■ XTPL's general work area



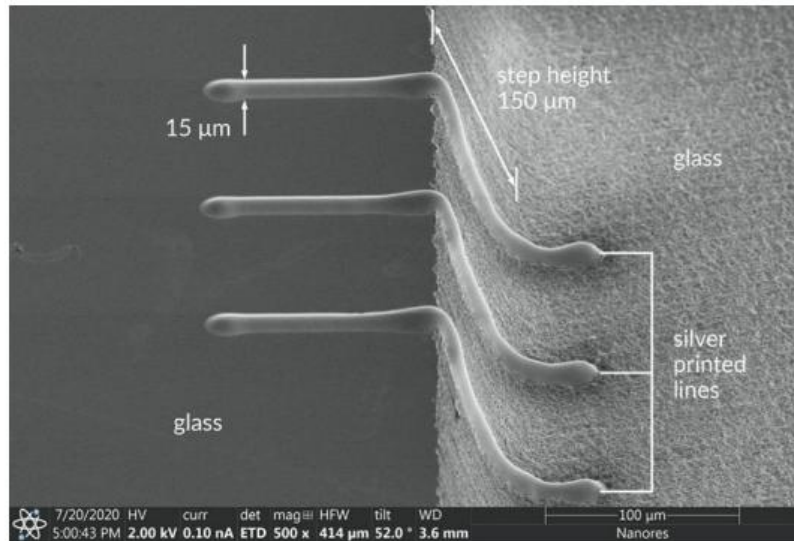
Source: XTPL

Can we print with UPD in 2.5D and 3D?

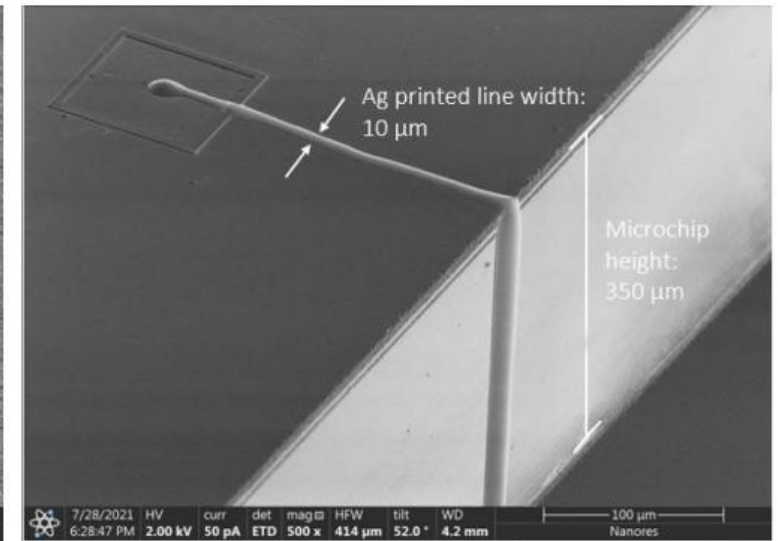
Covering vertical steps even above 300 μm height



12 μm step



150 μm step

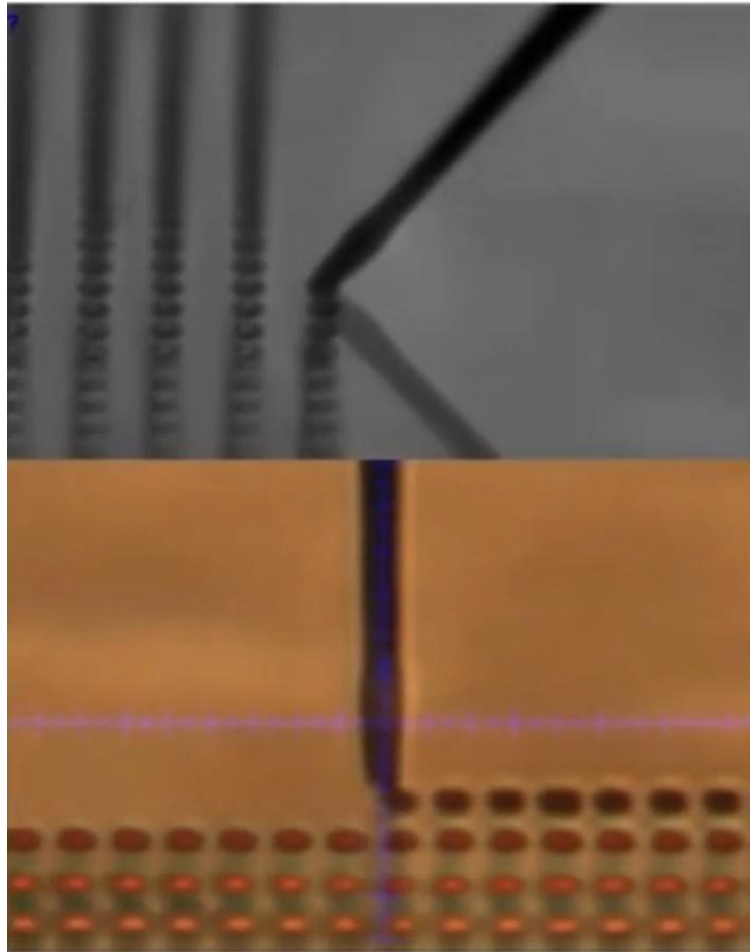


350 μm step

Source: XTPL

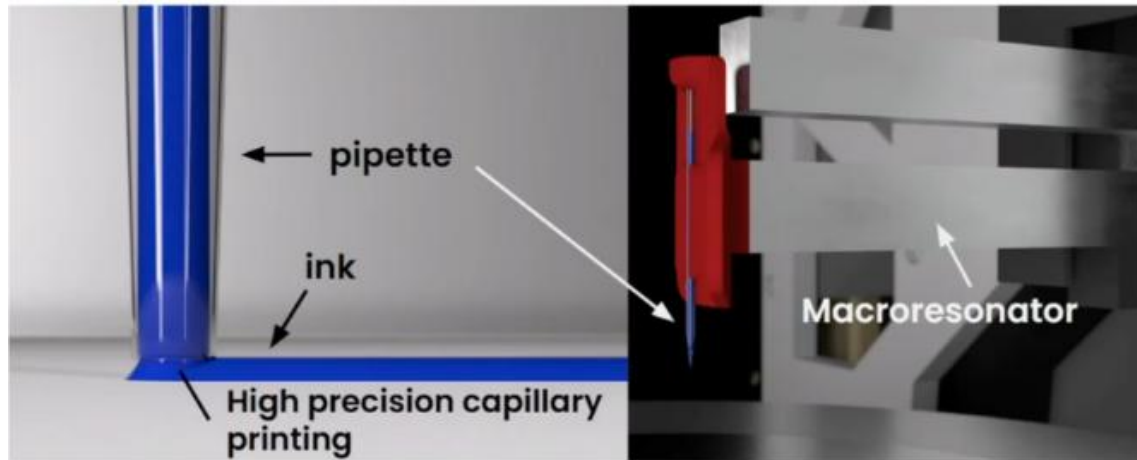
Too slow?!

8.3 dots per second



Source: XTPL

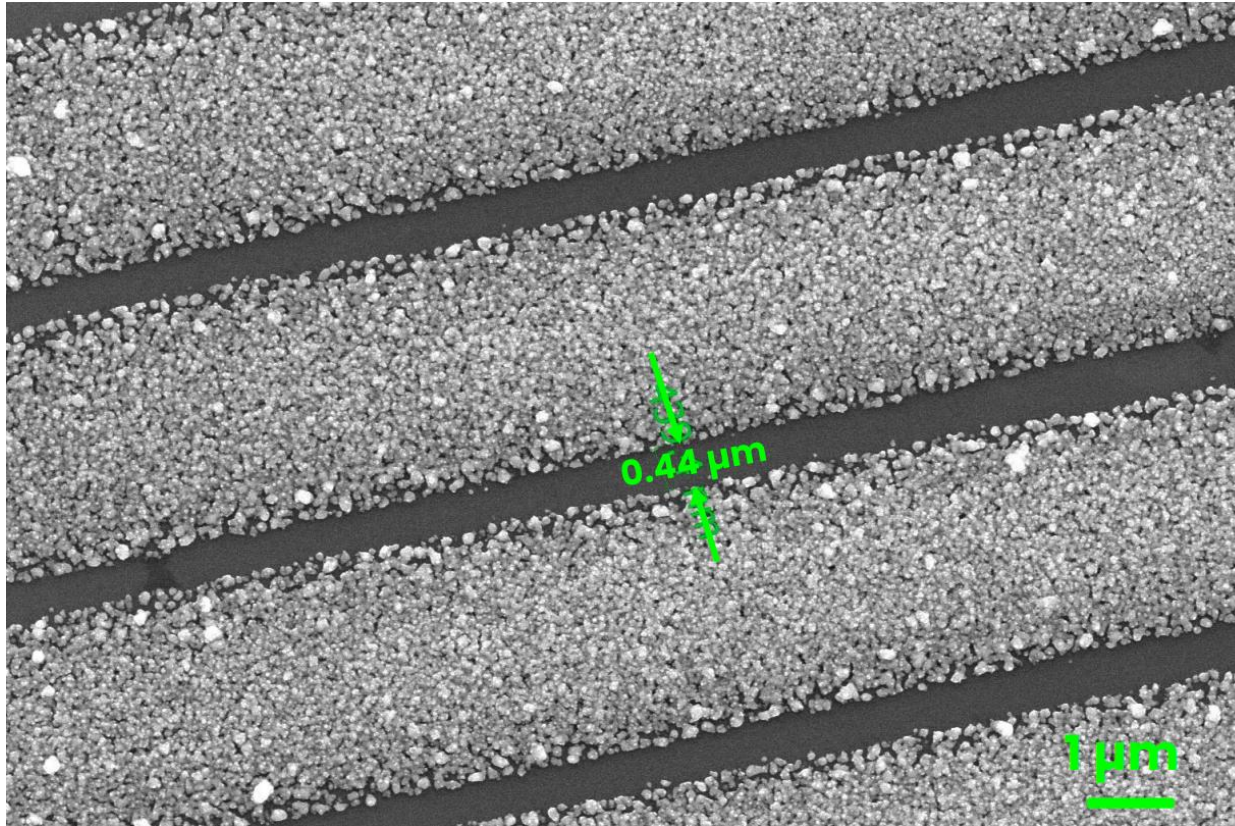
High Pressure Capillary Printing



No satellite or no splashing since printing head is very close

Source: Hummink

Fineline and even single-print micro-bumps



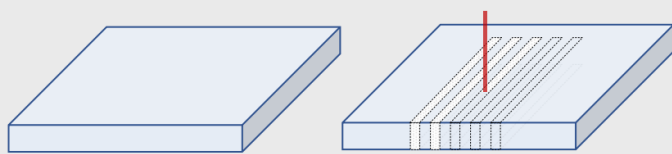
Source: Hummink

Microbump printing

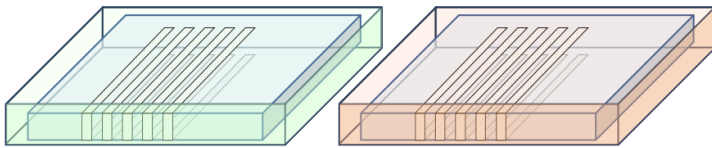


And can we additively manufacture WITHOUT inks??

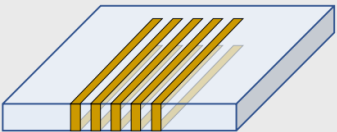
SSAIL Process: Additive laser-induced metalisation of diverse surfaces

1.

Laser process on blank substrate
(including via drilling if needed)

2.

Chemical process
1) Activation
2) Electroless plating

3.

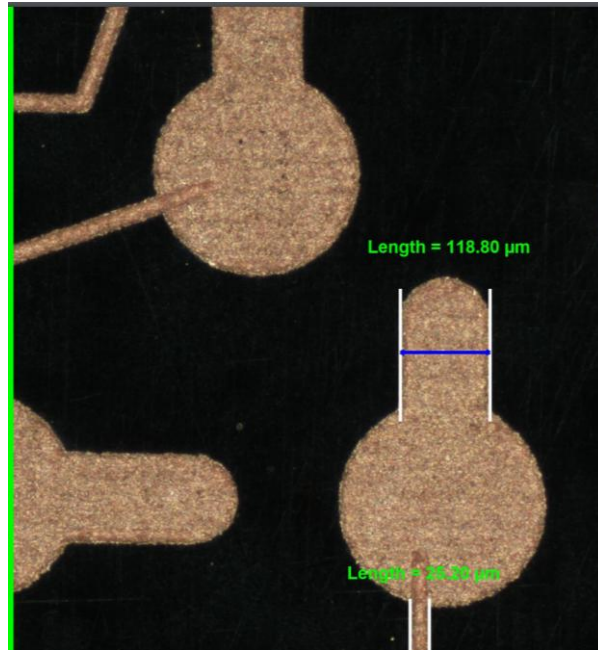
Final plated part

- Trace width down to 1 μm , sweet spot at $\sim 10 \mu\text{m}$
- Laser writing speed: $>3 \text{ m/s}$ @ $10 \mu\text{m}$
- Laser writing speed: $>0.2\text{--}1 \text{ m/s}$ @ $2 \mu\text{m}$
- Electroless plating: $3\text{--}4 \mu\text{m/h}$
- Process temperature: $<70^\circ\text{C}$
- Conforms to automotive adhesion requirements

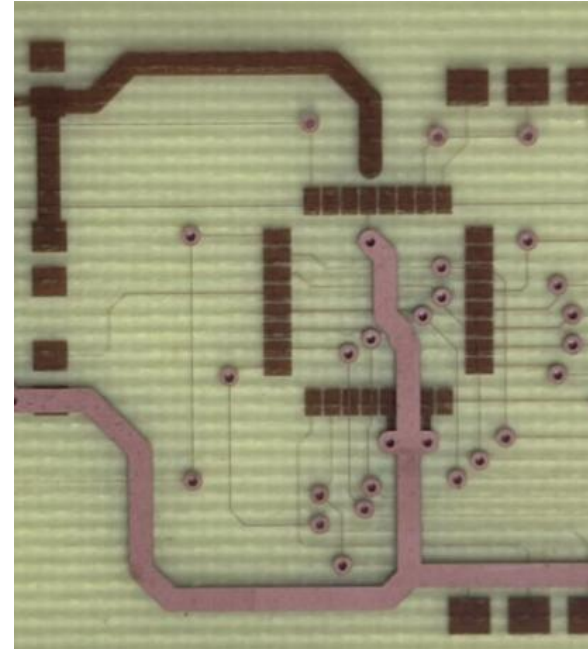
Source: Akoneer



Fan Out on PI



15μm on FR4 (sensitive surface!)

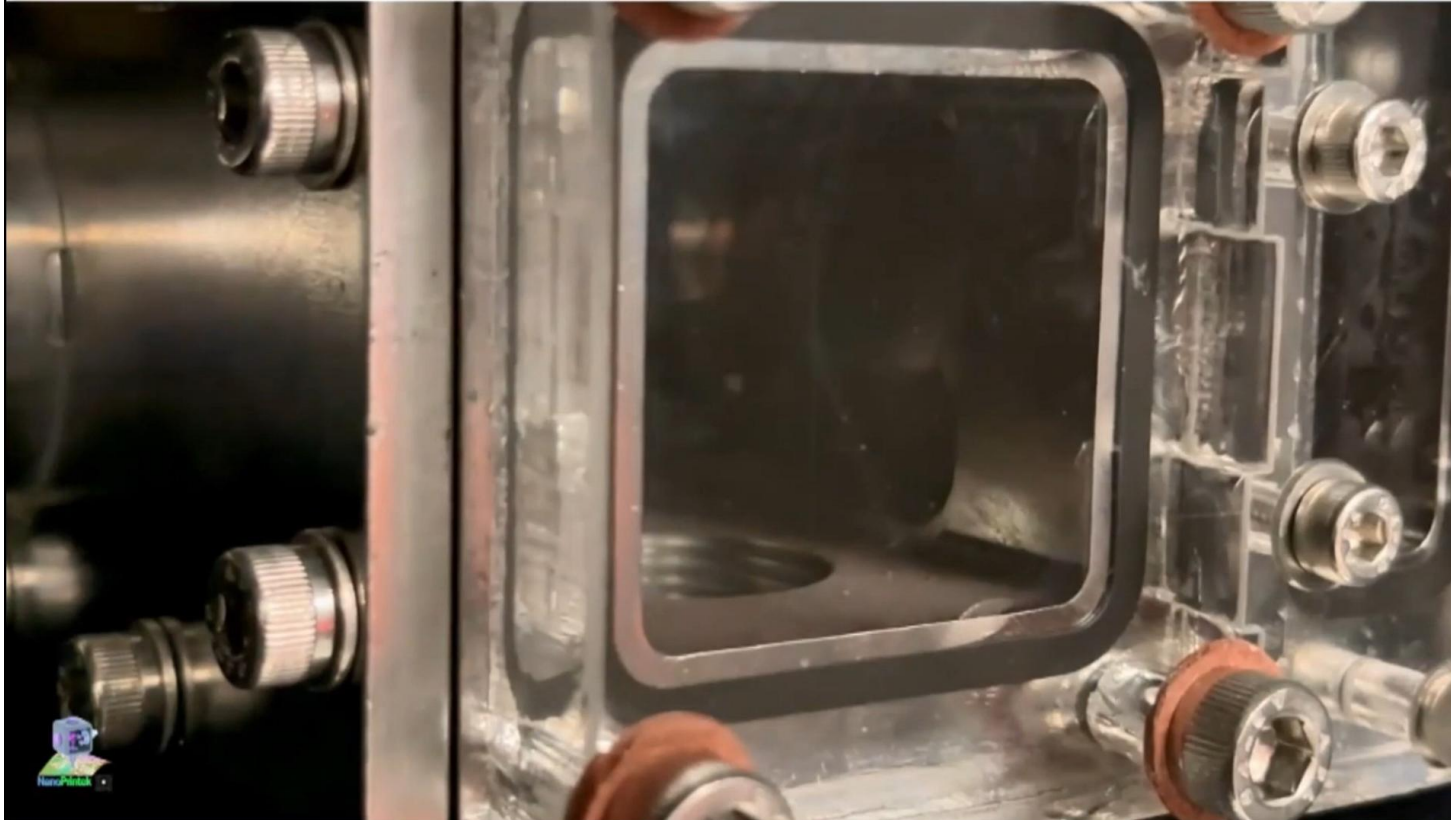


Source: Akoneer

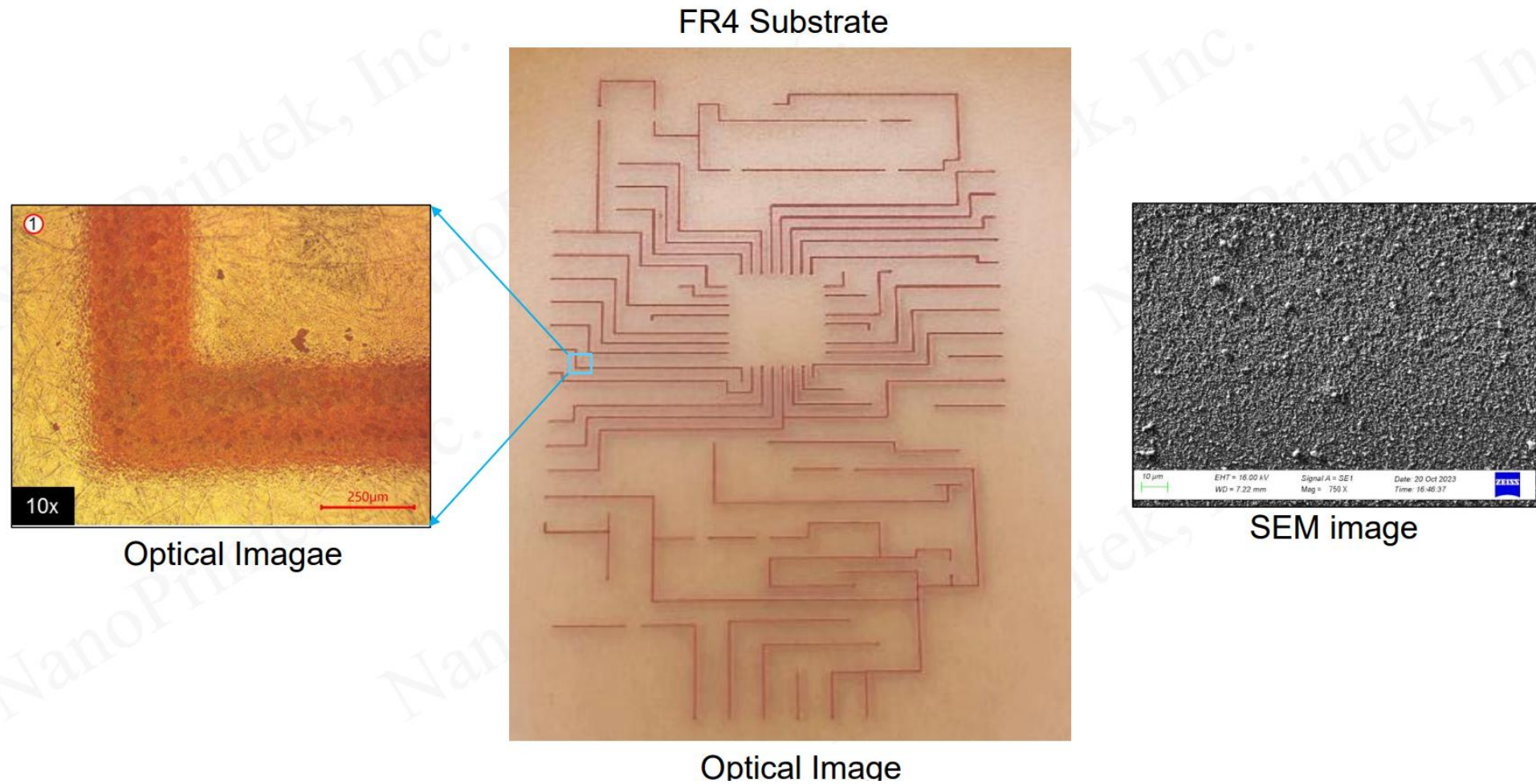
10/10 μm TRACES ON GLASS

200 μm

DRY (**Ink-Less!**) Mutli-material Printing

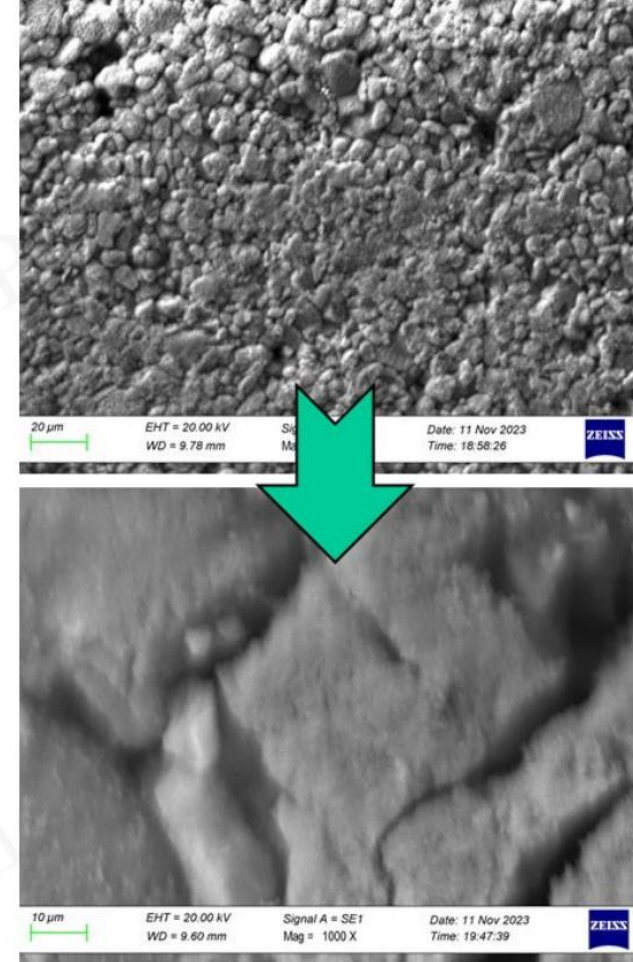
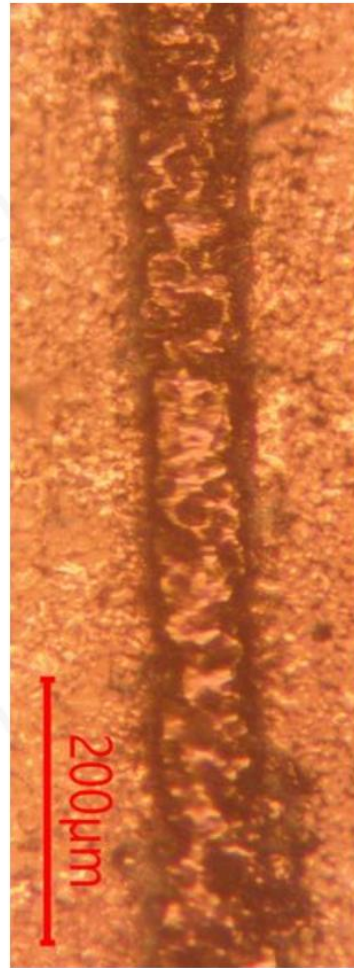
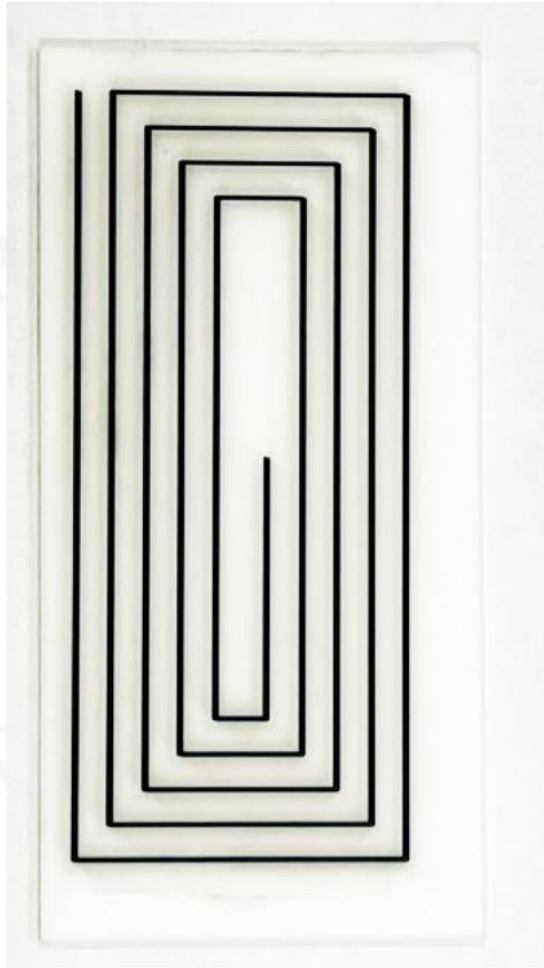


Source: NanoPrintek



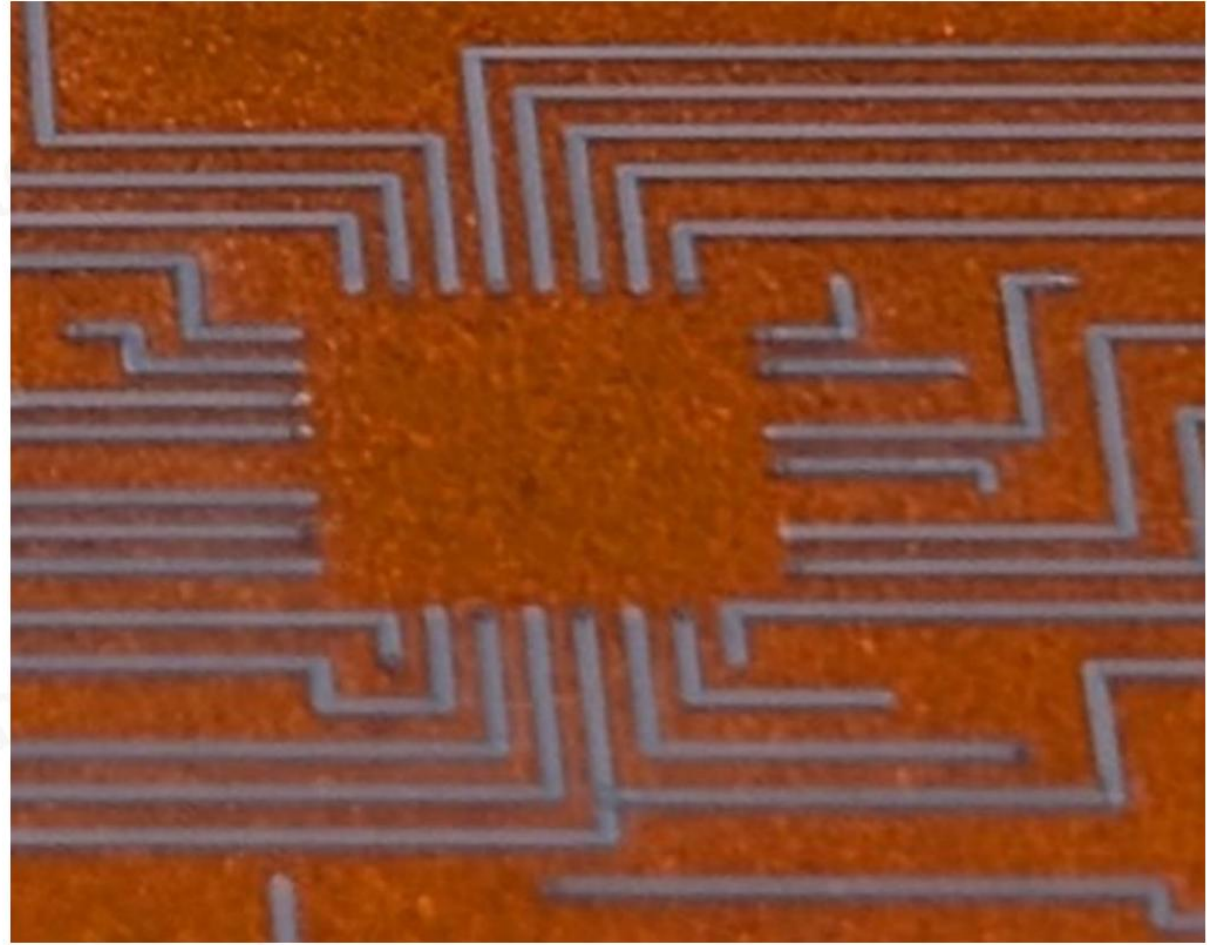
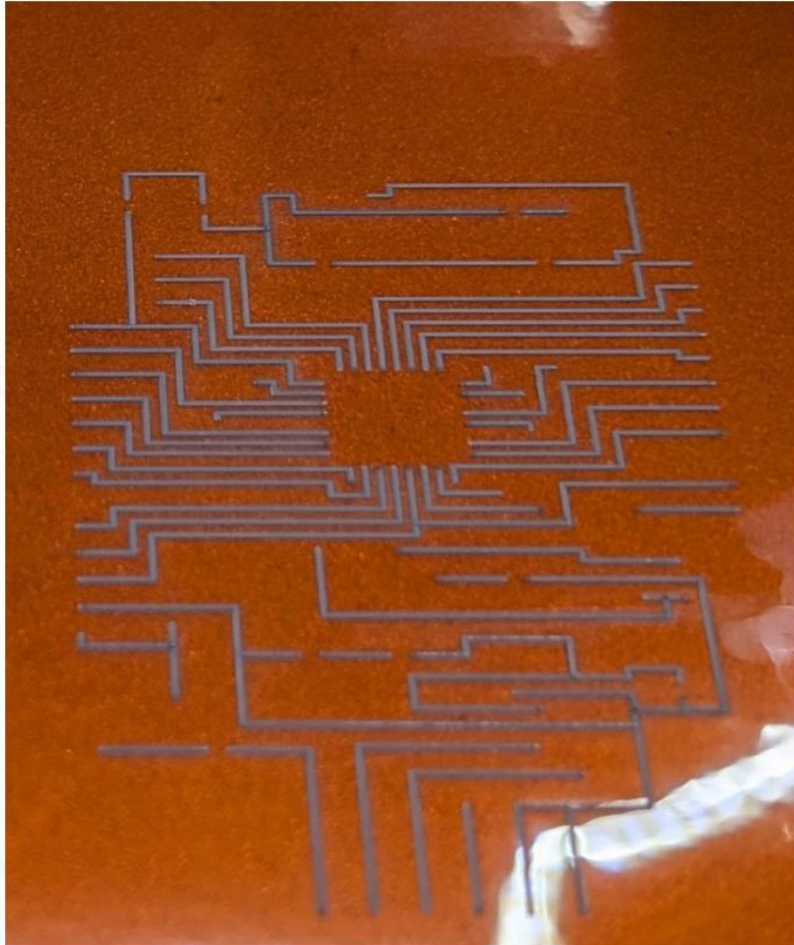
Source: NanoPrintek

Tungstan



Source: NanoPrintek

Platinum



Thank you

Printed Electronics Is Everywhere



THE FUTURE OF ELECTRONICS RESHAPED

BOSTON • USA • 2025
11-12 JUNE
CONFERENCE • EXHIBITION

70+

SPEAKERS

TALKS 11 JUNE		
TRACK 1	TRACK 2	TRACK 3
RIT Nashua Boeing Essemtec	SPARK GE HealthCare Heraeus C-INK	MARYLAND priways CREATIVE MATERIALS
EPICORE SYSTEMS VTT GlucocMedicum Nagase ChemteX	HRL NOTION DRACULA C-INK	Answer Science NON-CENTRIX Jris Panacol
IEE GREENSOURCE Henkel KIMOTO	100TECH ATLANT 3D TEXAS	GrapheneDx SunChemical IdentifySensors
ACI MATERIALS Satosen NC STATE UNIVERSITY	Panasonic CARBIDE CHEM MADICO CHEM	Georgia Tech ETS UNIVERSITY OF CHICAGO
DRINKS RECEPTION		

TALKS 12 JUNE	
TRACK 1	TRACK 2
AmbAI Jones spgprints FEDRIGONI	Fraunhofer Linxens POLICROM 日本ガリシ
3DFlexible Altium RTX	WPI ARKEVA NAUTILUS DEFENSE
NEXTFLX tracxon BKA STATE UNIVERSITY	conductive technologies Model Cardio
E'ink DEVCOM	MIT NM STATE VIBRANTZ
EVENT ENDS	

75+

EXHIBITORS

Essemtec
 Henkel
 Nagase ChemteX America
 Heraeus Electronics
 NOTION SYSTEMS

ACI MATERIALS

AKONEER

Altium

CREATIVE MATERIALS

East West

KIMOTO

Linxens

HUMAMINK

INO

imageXpert

INTELLVATION

KIMOTO

POLICROM

priways

Panacol

Panasonic

SUNRAY

SUSS

tracxon

SEFAR

VOLTERA

X73L

COVEMA

AGFA

A3Lysen

ARKEVA

ButFactory

Bridford Womersley

Coppprint

LISAT

Facklek

Fraunhofer

POLARIS KASO

GMI

Nanointegrative

KIMOPR

LISAT

METALOR

VIBRANTZ

GUTINTERFACE

nsm

Nagase ChemteX

VFP

NBC

TECHNIC

XENON

VFP



THE FUTURE OF ELECTRONICS RESHAPED

BERLIN • EU • 2025
22-23 OCT
CONFERENCE • EXHIBITION

Perovskite⁺Connect  THE FUTURE OF ELECTRONICS **RESHAPED**

The Co-Located Events Will Jointly Welcome



550

PARTICIPANTS



80

EXHIBITORS



70

PRESENTATIONS



12

MASTERCLASSES





4

TOURS

22-23 OCTOBER
2025

THE FUTURE OF ELECTRONICS
RESHAPED

FLOORPLAN EUROPE

 RESERVED
 BOOKED

Co-located with

Perovskite⁺Connect

